

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No. M-8555 US		Serial No. 09/578,798	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant Jaime Poris			
				Filing Date May 23, 2000		Group Unknown 2873	
U.S. Patent Documents							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
Foreign Patent Documents							
		Document	Date	Country	Class	Subclass	Translation Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
W.C.	AQ	Makosch, G., "LASSI - a scanning differential ac interferometer for surface profile and roughness measurement" <i>SPIE Vol. 1009</i> (1988); Pages 244-253.					
	AR						
	AS						
Examiner <i>W.C.</i>		Date Considered <i>7/25/02</i>					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							